

# SIEMENS

PATENT  
Attorney Docket No. 2001P13794WOUS

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Inventor:	D. Fischer et al.	)		
		)	Group Art Unit:	2121
Serial No.:	10/763,786	)		
		)	Examiner:	Chang, Sunray
Filed:	January 23, 2004	)		

Title: **PROCESS CONTROL SYSTEM WITH A CHARGING FUNCTION**

Mail Stop Amendment  
**Commissioner For Patents**  
P.O. Box 1450  
Alexandria, VA 22313-1450

### RESPONSE UNDER 37 CFR 1.111

Sir:

In response to the Office Action mailed June 5, 2007, Applicants respectfully submit the following response in connection with the above-identified application.

### REMARKS

All pending claims are newly rejected under 35 USC 102(e) or 35 USC 103(a) based upon Omshehe or a combination of Omshehe and another reference.

MPEP §706 states that "The goal of examination is to clearly articulate any rejection early in the prosecution process so that the applicant has the opportunity to provide evidence of patentability and otherwise reply completely at the earliest opportunity. 37 CFR 1.104 (c)(2) further requires that "The pertinence of each reference, if not apparent, must be clearly explained